

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Docket Number (Optional) NSC1-G2511 [P04437 D2]		Application Number N 10-736194
	Applicant(s) Peter J. Hopper		
	Filing Date 12-15-02	Group Art Unit 3825	

### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
NL	*AA	5,128,737	07/07/92	van der Have	257	503	03/02/90
NL	*AB	5,635,753	06/1997	Hofflinger et al.	257	621	12/30/92
NL	*AC	5,734,187	03/31/98	Bohr et al.	257	377	06/16/97
NL	*AD	6,084,304	07/04/00	Huang et al.	257	762	06/05/98
NL	*AE	6,136,640	10/24/00	Marty et al.	438	239	07/17/98
NL	*AF	5,164,334	11/17/92	Mizushima	437	203	12/26/90
NL	*AG	2001/0002072	05/31/01	Ireland	257	758	12/15/00

### FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
NL	*AH	JP-11-352512	12/24/99	Japan	G02F	1/136	X	

### OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

NL	*AI	Stanley Wolf, "Silicon Processing for the VLSI ERA", Volume 2: Process Integration, 1990, pp. 183-186.					

Examiner Nami	Date Considered 10/25/04
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	